

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78564

Nobuo UOTANI, et al.

Appln. No.: 10/579,406

Group Art Unit: 1793

Confirmation No.: 1349

Examiner: Pegah PARVINI

Filed: May 15, 2006

For: POLISHING COMPOSITION AND POLISHING METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 30, 2008, please amend the above-identified application as follows on the accompanying pages.

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